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	Application No.	Applicant(s)	
Notice of Allowability	10/690,159	MICHALICEK, MARI	K A.
	Examiner	Art Unit	
	Thao P. Le	2818	•
The MAILING DATE of this communication at All claims being allowable, PROSECUTION ON THE MERIT herewith (or previously mailed), a Notice of Allowance (PTOL NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATEN of the Office or upon petition by the applicant. See 37 CFR 1	S IS (OR REMAINS) CLOSED ir -85) or other appropriate commi T RIGHTS. This application is s	n this application. If not include unication will be mailed in due	ed course. THIS
1. This communication is responsive to 10/24/2005.			
2. 🔀 The allowed claim(s) is/are <u>13-20</u> .			·
 3. ☐ Acknowledgment is made of a claim for foreign priori a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents 		or (f).	· · · · · · · · · · · · · · · · · · ·
2. Certified copies of the priority documents		on No	
3. Copies of the certified copies of the priorit	y documents have been receive	d in this national stage applicat	tion from the
International Bureau (PCT Rule 17.2(a)).		,,	
* Certified copies not received:	e e e e e e e e e e e e e e e e e e e		
Applicant has THREE MONTHS FROM THE "MAILING DA noted below. Failure to timely comply will result in ABANDOTHIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be SINFORMAL PATENT APPLICATION (PTO-152) which	ONMENT of this application.	AMINER'S AMENDMENT or N	
		designation to denote.	
 CORRECTED DRAWINGS (as "replacement sheets") (a) including changes required by the Notice of Drafts 		u (DTO 049) attached	
1) hereto or 2) to Paper No./Mail Date		(FTO-940) attached	
(b) ☐ including changes required by the attached Exam Paper No./Mail Date		r in the Office action of	
Identifying indicia such as the application number (see 37 C each sheet. Replacement sheet(s) should be labeled as sucl	FR 1.84(c)) should be written on t n in the header according to 37 CF	he drawings in the front (not the FR 1.121(d).	back) of
 DEPOSIT OF and/or INFORMATION about the d attached Examiner's comment regarding REQUIREME 	eposit of BIOLOGICAL MATI ENT FOR THE DEPOSIT OF BIO	ERIAL must be submitted. N DLOGICAL MATERIAL.	lote the
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Attachment(s)	<i>-</i>	Samuel Date 1 A . 4' . 4'	
1. Notice of References Cited (PTO-892)		formal Patent Application	
 Notice of Draftperson's Patent Drawing Review (PTO-9 		ummary (PTO-413), /Mail Date	
3. Information Disclosure Statements (PTO/SB/08),		Amendment/Comment	
Paper No./Mail Date <u>10/16/2003</u> 4. Examiner's Comment Regarding Requirement for Depo of Biological Material	sit 8. ⊠ Examiner's	Statement of Reasons for Allo	wance
	/ 9. ☐ Other	_ •	

DETAILED ACTION

Election/Restrictions

Applicant's election of claims 13-20 in the reply filed on 10/24/2005 is acknowledged. Because applicant did not distinctly and specifically point out the supposed errors in the restriction requirement, the election has been treated as an election without traverse (MPEP § 818.03(a)).

Examiner's Amendment

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The Application has been amended as follows:

Cancel Claims 22-46 due to non-elected claims.

Reason for allowance

Claims 13-20 are allowed. The following is an examiner's statement of reason for allowance: None of the references of record teaches or suggests the claimed limitations having a MEMS device comprising: an edge hinges-inclusive multi layer covered sacrificial first substrate member, a MEMS module protective shield member on the first substrate edge hinges, a MEMS module suspended from the MEMS module protective shield member by a plurality of ether members, a MEMS module protective shield

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member latch assembly supporting the MEMS module protective shield member and the MEMS module in a selected substrate-removed location, and a second substrate member-received MEMS controller electronic circuit die located in the selected substrate-removed location within tether members distance of the latch assemblystabilized MEMS module protective shield member, the MEMS module protective shield member enabling safe manipulative positioning and safe liquid bath-engagement of the MEMS module during removed substrate, tethered, handling, positioning and processing of the module and among other limitations cited in independent claim 13.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao P. Le whose telephone number is 571-272-1785. The examiner can normally be reached on M-F (8-6).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor Steven H. Loke can be reached on 571-272-1657. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

/Thao Le/ Thao P. Le Primary Examiner August 23, 2007. Page 4